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Amendment in response to Office Action mailed 1/11/2002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re: US Patent Application 09/934,817 ✓
Filed August 21, 2001 ✓
Title **Optical Arrangement and Projection Illumination Equipment for** ✓
Microlithography with Passive Thermal Compensation
Applicant Wagner ✓
Art Unit 2858 ✓
Examiner Etienne (Steve) LaRoux ✓
Telephone (703) 305-0620
Attorney Docket (Z) C98003 P US

Box Response
Commissioner for Patents
Washington, DC 20231

Amendment

Dear Examiner LaRoux:

This amendment responds to the Office Action mailed January 11, 2002.

In the Claims:

Following is a clean set of the claims in this case. A **"Version with Markings to show Changes Made"** is included as an addendum to this Amendment.

1. An optical arrangement, comprising:

a light source that emits radiation,

a mount,

an optical element fastened in said mount,

wherein said optical element is acted on by said radiation such that a heat supply results from said radiation that lacks symmetry corresponding to the shape of said optical element, and

a connecting structure between said optical element and said mount, having a symmetry characteristic that does not correspond to the shape of the optical element.

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Wagner
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